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CONFIRMATION NO. 8712

<b>SERIAL NUMBER</b> 10/650,886	<b>FILING OR 371(c) DATE</b> 08/28/2003 <b>RULE</b>	<b>CLASS</b> 134	<b>GROUP ART UNIT</b> 1763	<b>ATTORNEY DOCKET NO.</b> TSM6283131RI
<b>APPLICANTS</b> Horng-Wen Chen, Hsin-Chu, TAIWAN; Chi-How Wu, Tainan, TAIWAN;				
<b>** CONTINUING DATA *****</b> This application is a REI of 09/669,159 09/25/2000 PAT 6,283,131 <i>gag 6-041</i>				
<b>** FOREIGN APPLICATIONS *****</b> <i>gag 6-041</i>				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 02/22/2004</b>				
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged Examiner's Signature <i>gag 6-041</i> Initials		<b>STATE OR COUNTRY</b> TAIWAN	<b>SHEETS DRAWING</b> 6	<b>TOTAL CLAIMS</b> 58 <b>INDEPENDENT CLAIMS</b> 8
<b>ADDRESS</b> 25962				
<b>TITLE</b> In-situ strip process for polysilicon etching in deep sub-micron technology				
<b>FILING FEE RECEIVED</b> 1984	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	